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OCT 09 2002

TC 1700

Docket No.: M1071.1392
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yutaka Takeshima, et al.

Dated: October 4, 2002

Application No.: 09/916,804

Group Art Unit: 1762

Filed: July 27, 2001

Examiner: M. Barr

For: METHOD OF PRODUCING COMPLEX
OXIDE THIN-FILM AND
PRODUCTION APPARATUS

Commissioner for Patents
Washington, D.C. 20231

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Dated: October 4, 2002

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